

The logo for PRECISE, featuring the word in a bold, italicized, sans-serif font with a red and white graphic element at the end of the 'E'.

PRECISE

MICRO CORIOLIS MASS FLOW SENSOR FOR CHEMICAL MICROPROPULSION SYSTEMS

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ASTRIUM
AN EADS COMPANY



NANOSPACE



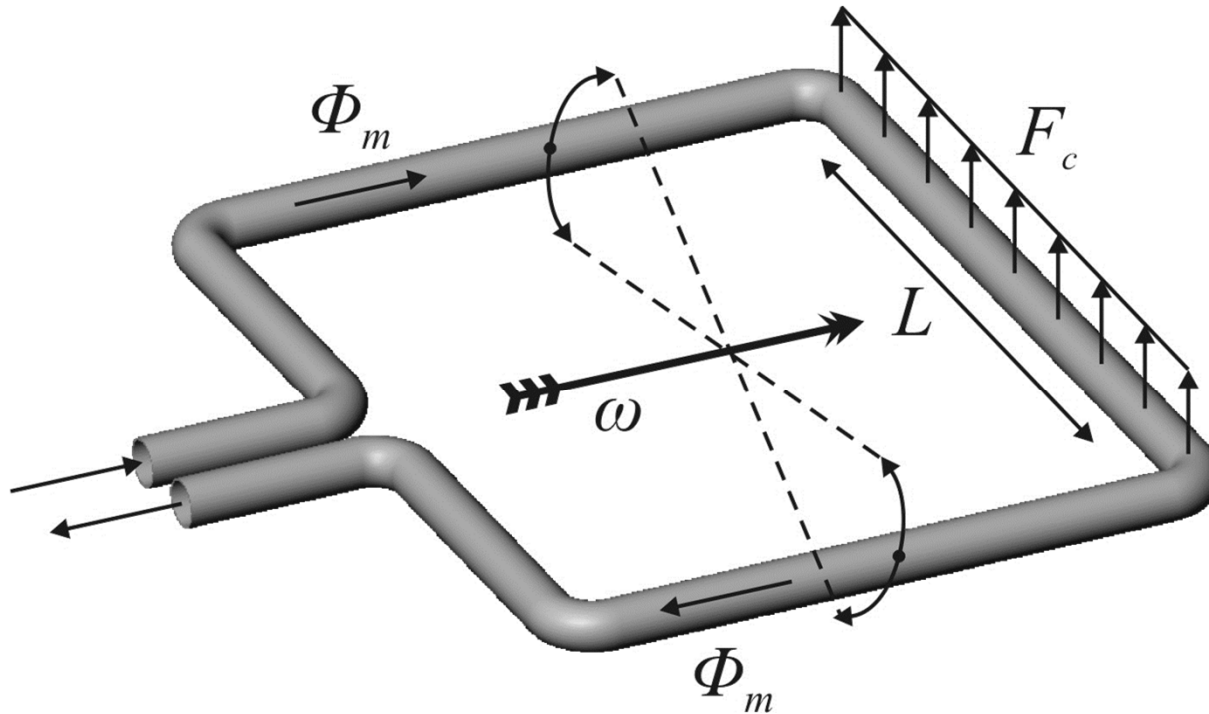
UNIVERSITY OF
SURREY

University of Twente
The Netherlands

Contents

- ▶ Operating principle
- ▶ Previous work / background
- ▶ Current status
- ▶ Fabrication process
- ▶ Characterisation results
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- ▶ Conclusions

Sensor structure and basic operating principle



$$\vec{F}_c = -2L \cdot \vec{\omega} \times \vec{M}_f$$

Why micro-Coriolis?

▶ Advantages:

Independent of:

- flow profile
- density
- temperature
- viscosity
- pressure
- homogeneity

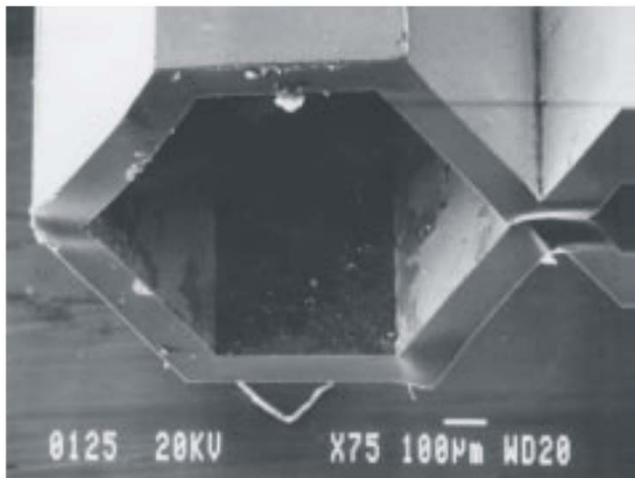
Less external mechanical influences due to low system mass / high resonance frequency

▶ Disadvantages:

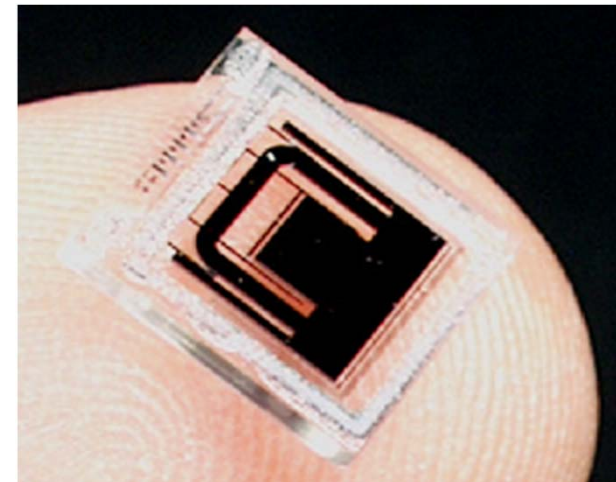
Higher stiffness + lower mass flow → lower signal
High manufacturing accuracy necessary

Previous work

- ▶ Worldwide 2 other groups active in the ‘MicroCoriolis’ field:
 - Enoksson, using silicon bulk micromachining and wafer bonding
 - ISSYS, using various bulk and surface micromachining techniques resulting in highly boron doped silicon tube walls



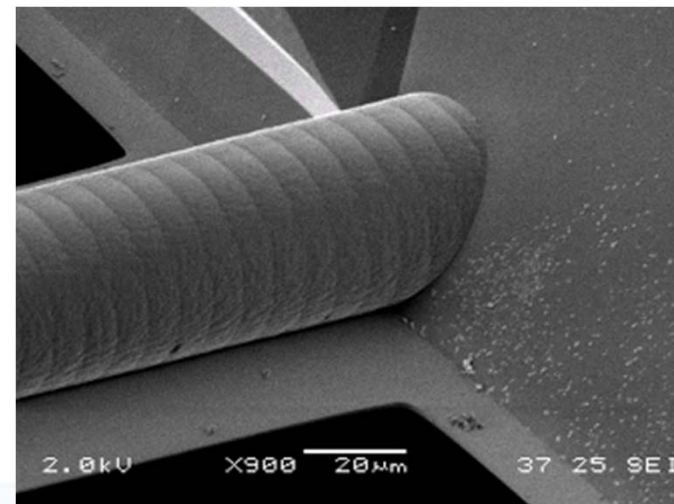
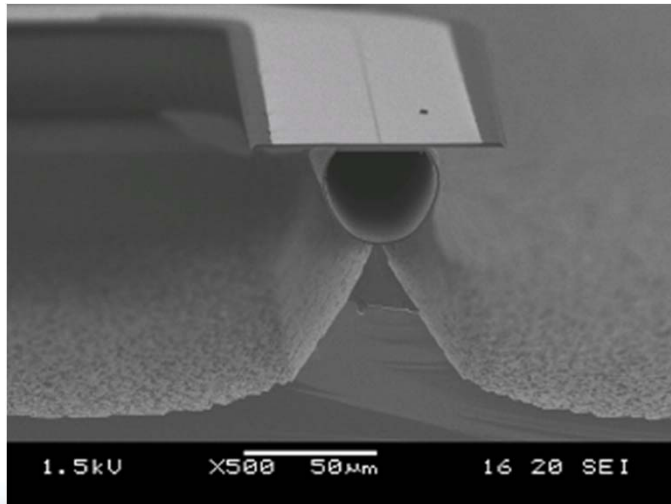
Silicon tube by Enoksson et al



ISSYS sensor

Our approach

- ▶ Use LPCVD silicon nitride tube walls
 - Thin (1.2 μm) but strong walls
 - Inert material
- ▶ Research started in 2006 within the MicroNed programme
- ▶ Continued in PIDON-HTF, NanoNextNL and PRECISE

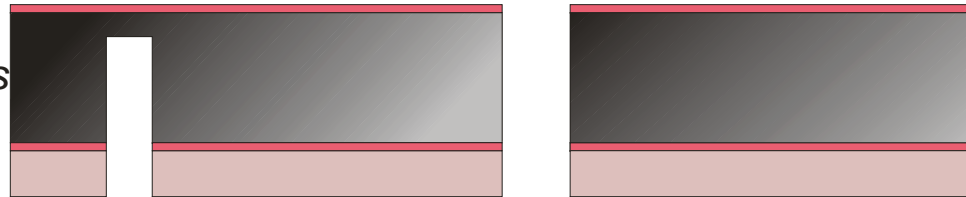


Process flow

deposit 500 nm SiRN



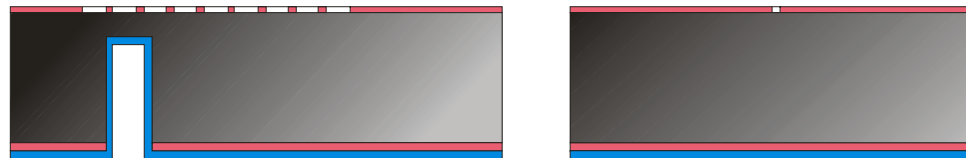
Etch back access holes



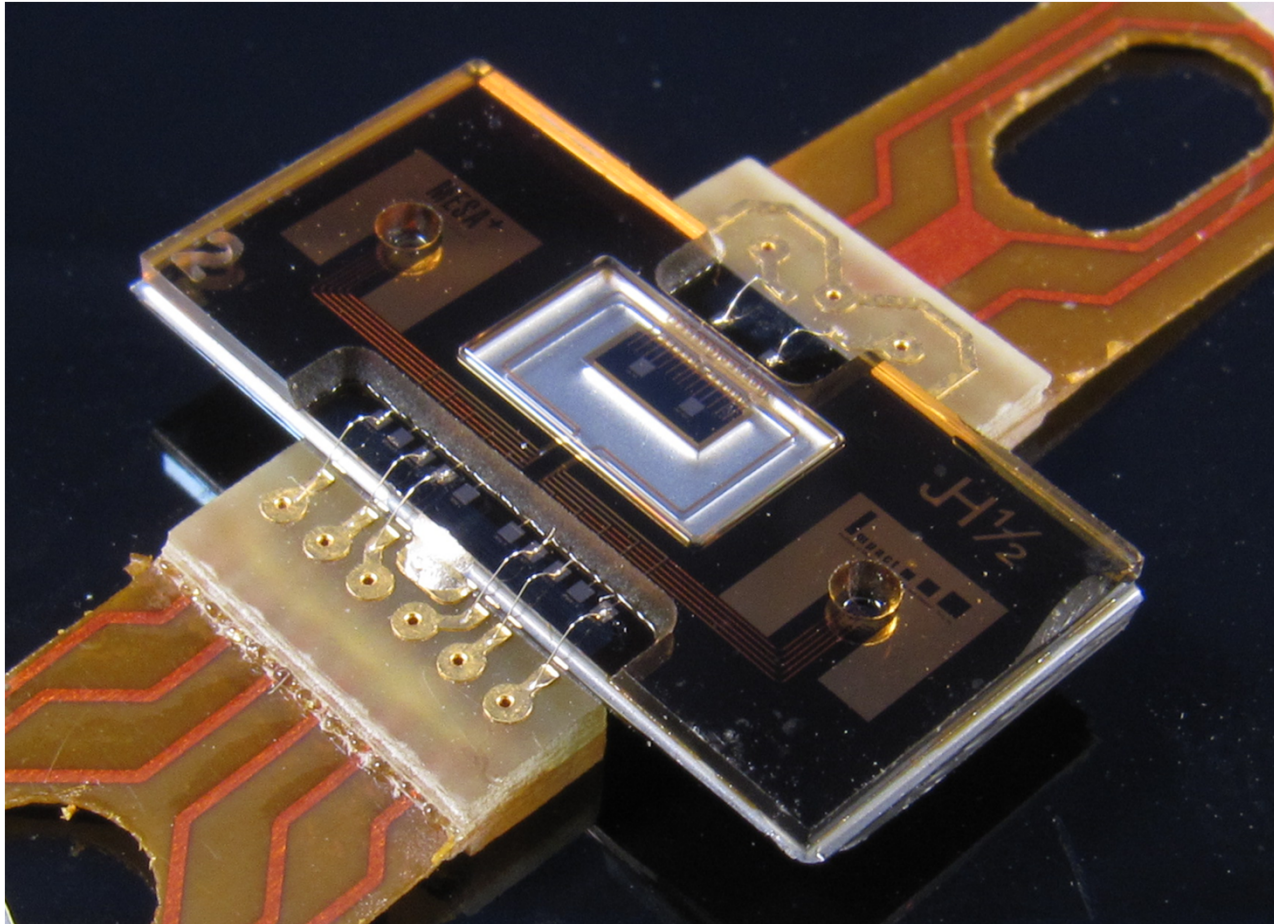
*deposit 500 nm TEOS
remove from frontside*



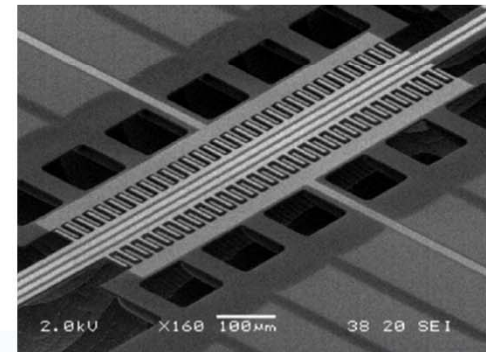
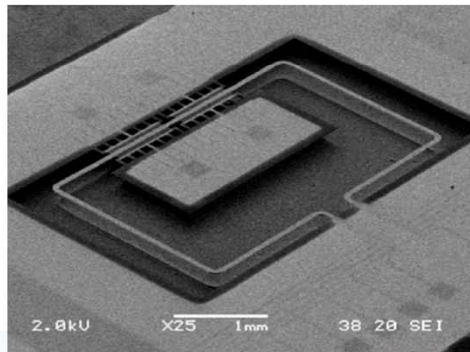
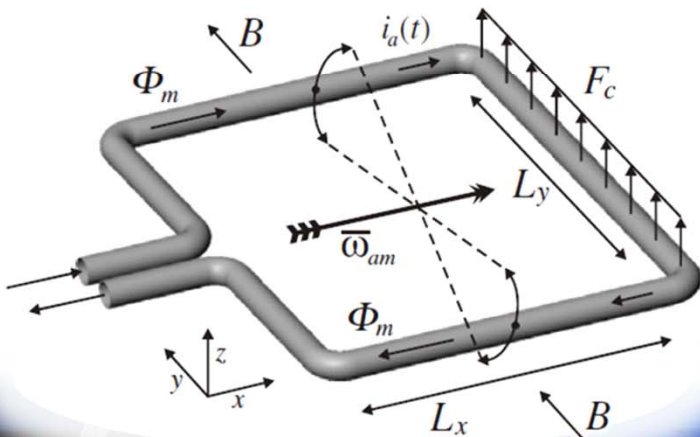
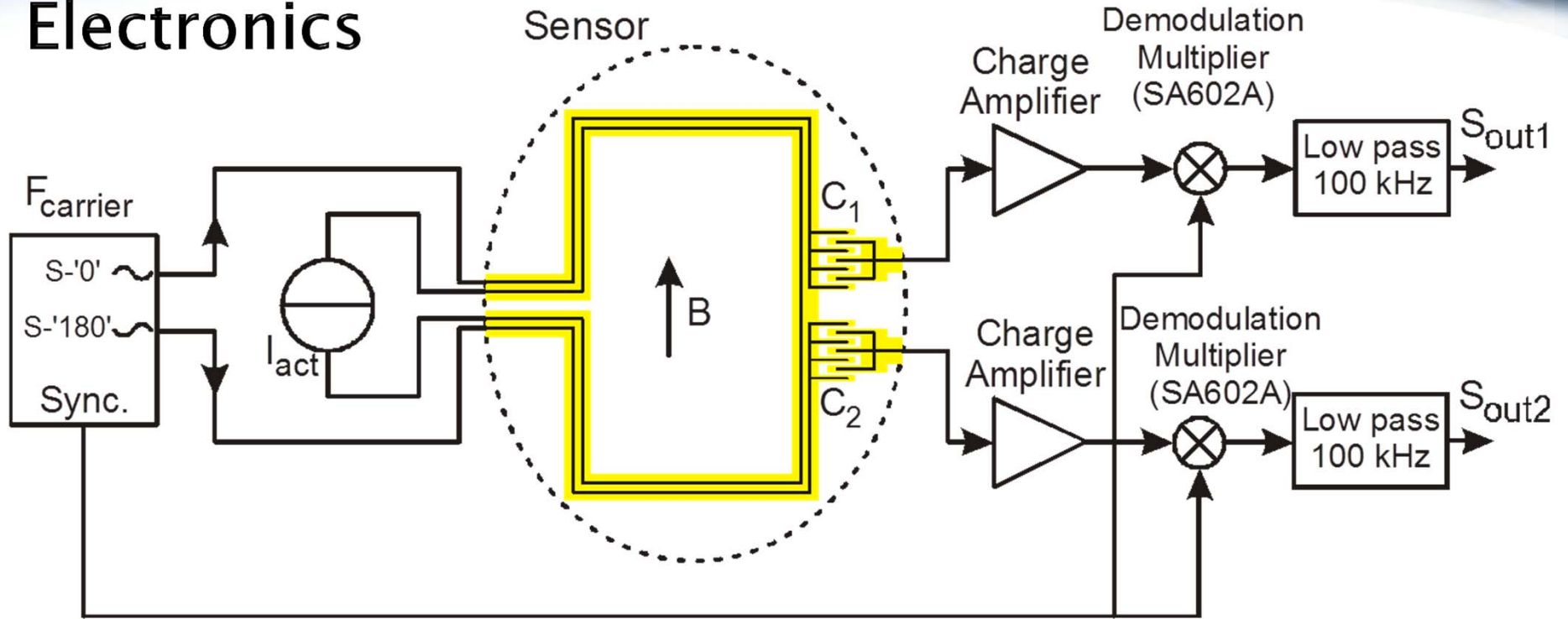
Pattern SiRN



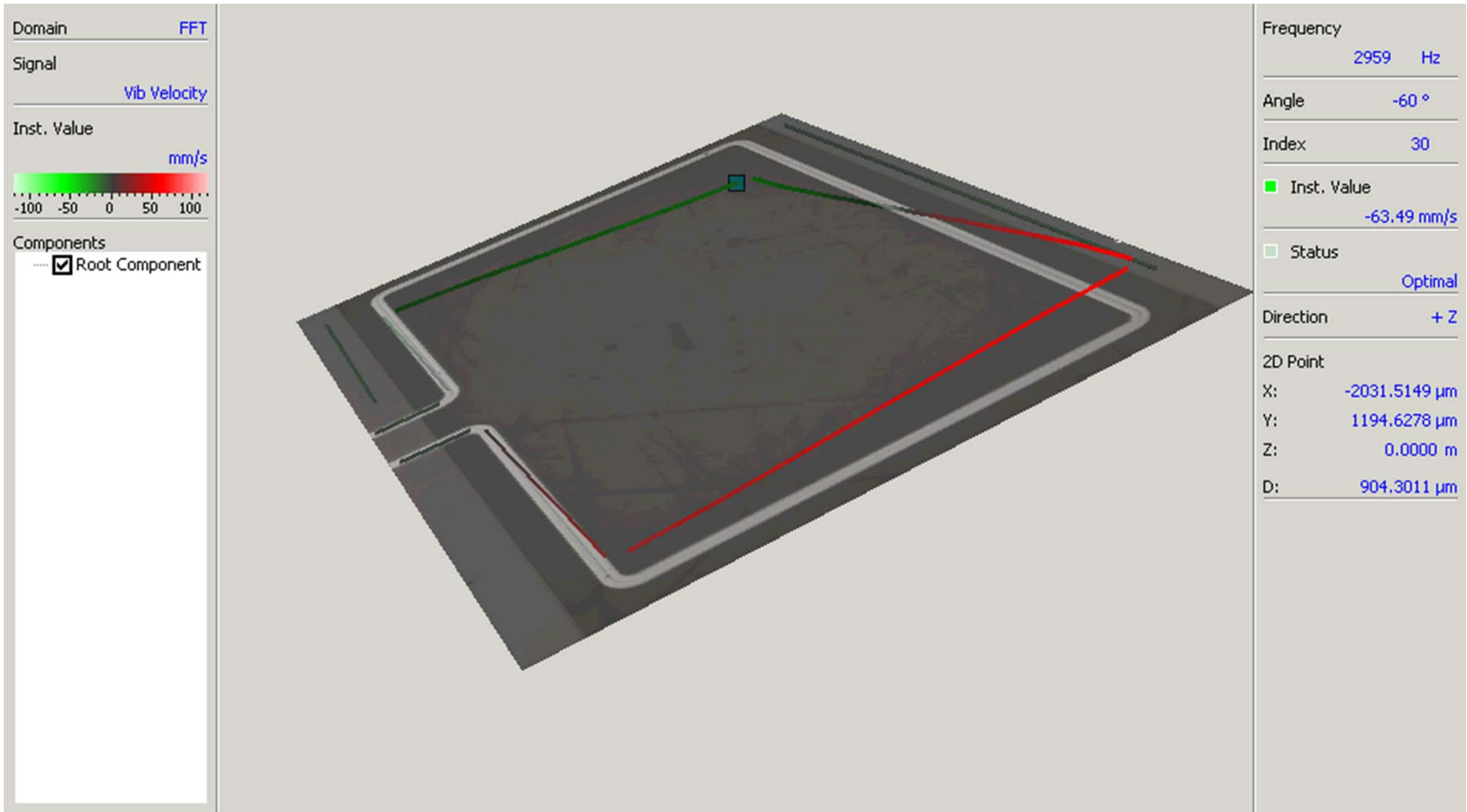
Current status

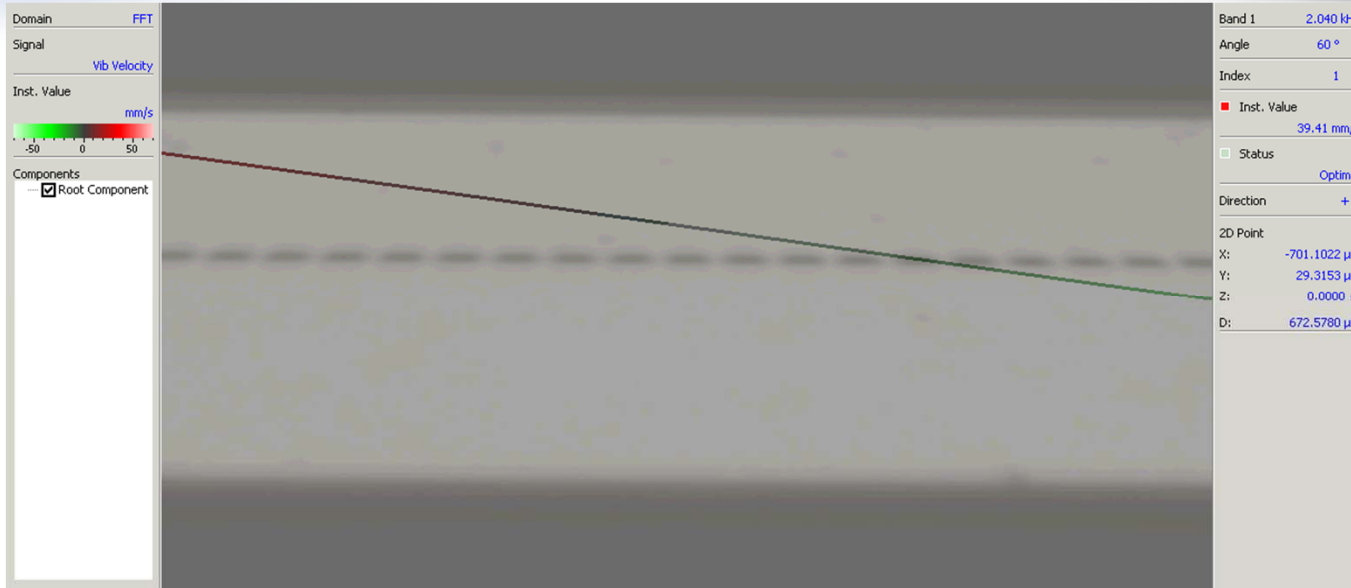


Electronics

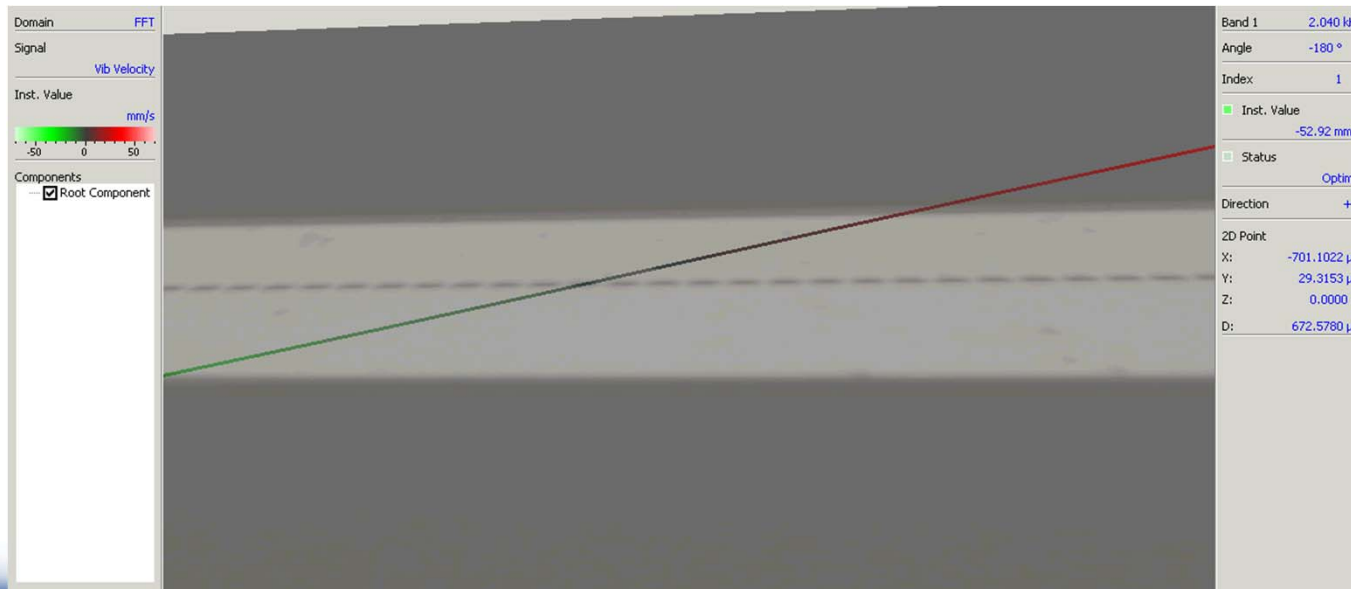


Vibrometer measurements



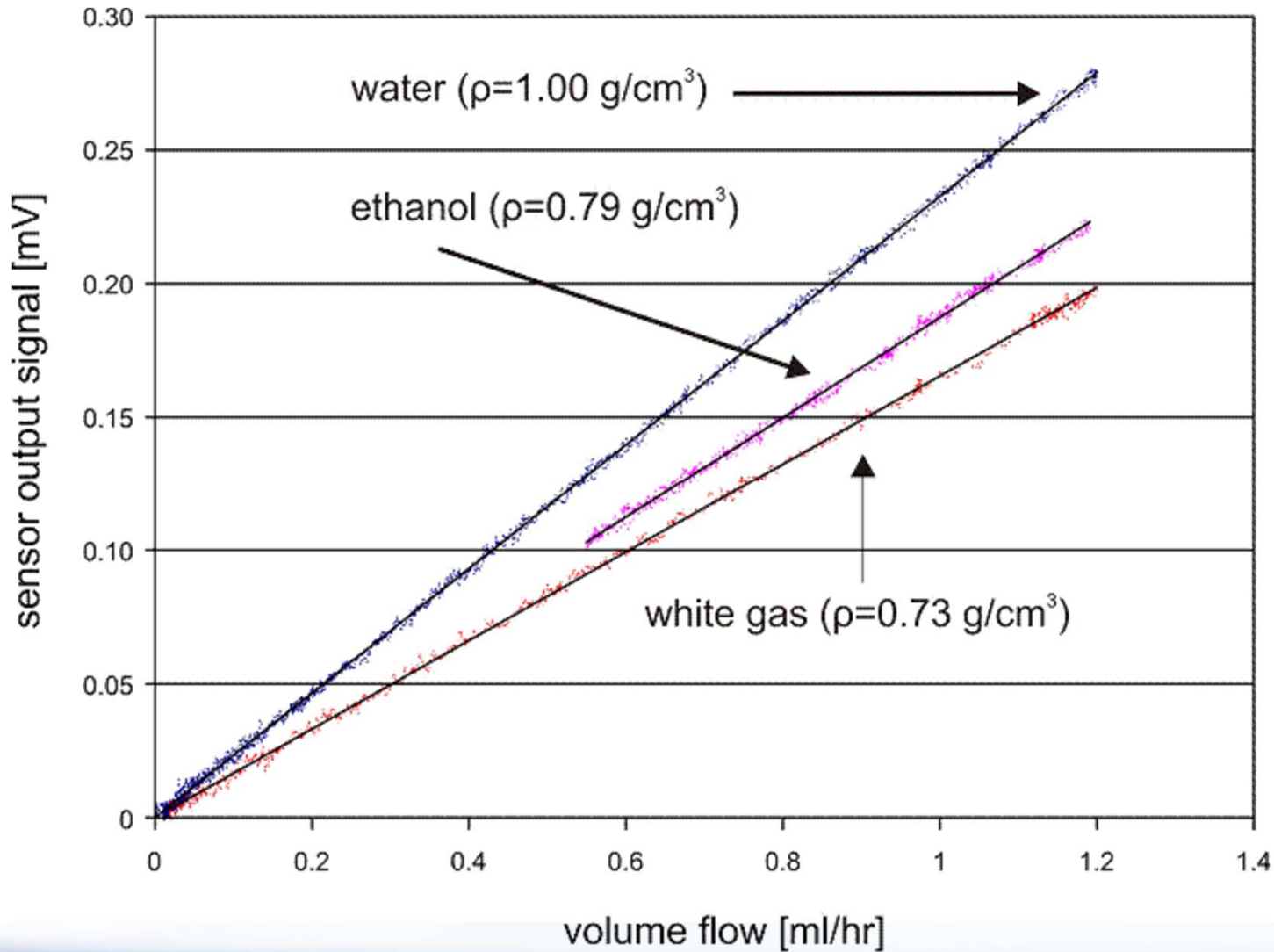


No flow

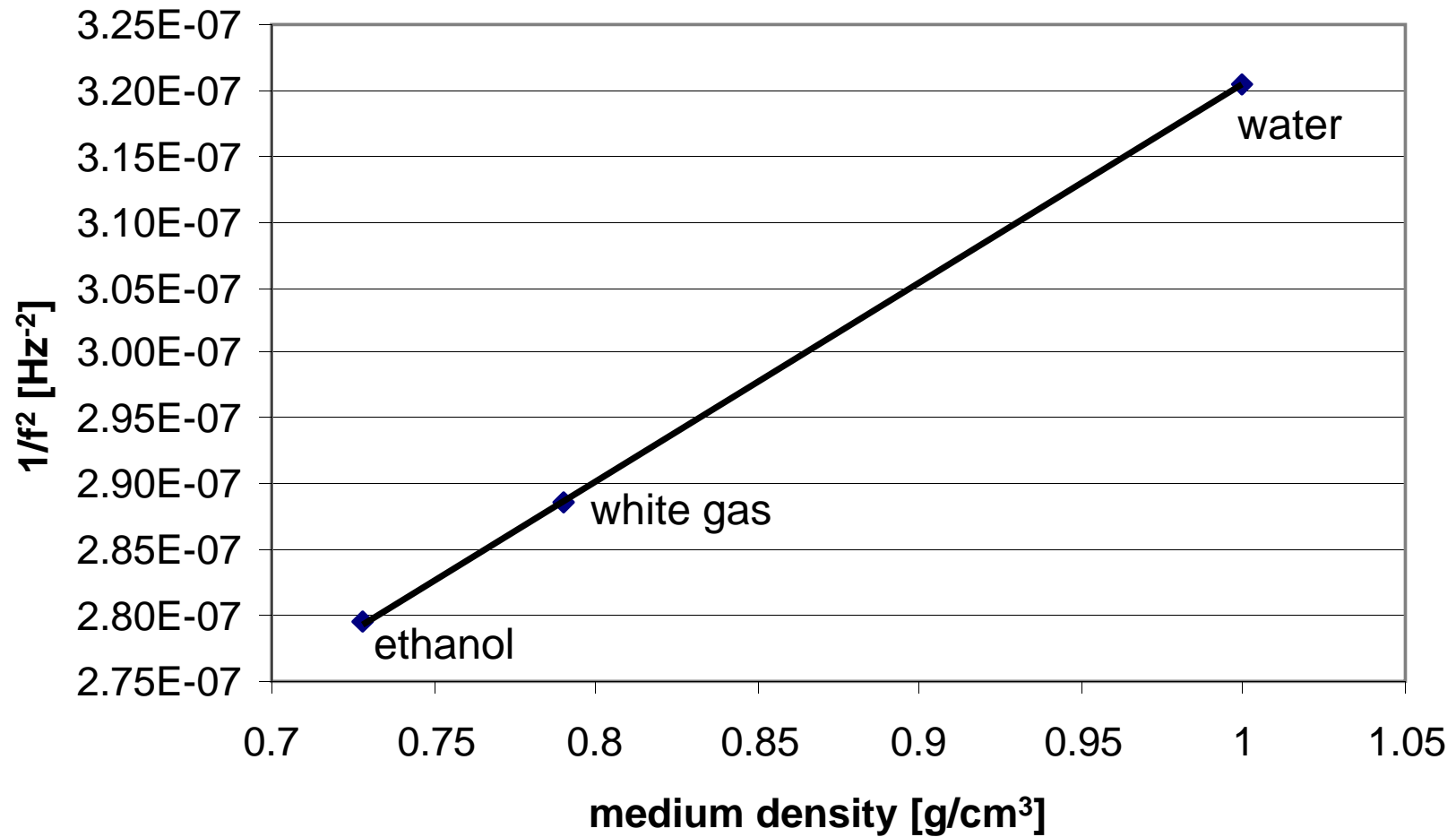


Max. flow

Mass flow measurements



Density measurements

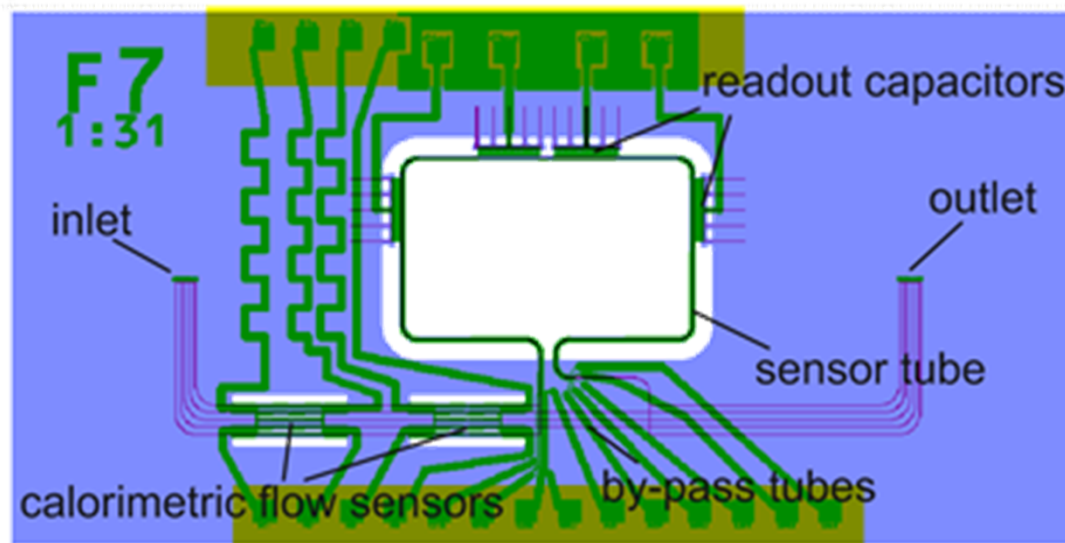


Towards hydrazine flow measurement

- ▶ Required full-scale mass flow 6 mg/s per thruster
- ▶ 24 mg/s for 4 thrusters
- ▶ Existing sensor has full-scale range of 0.3 mg/s
- ▶ We need to increase the flow range by a factor 20

New design uses on-chip by-pass channel

- ▶ Ratios ranging from 20 to 100 have been designed
- ▶ Designs with lowest sensitivity suitable for 4 thrusters together



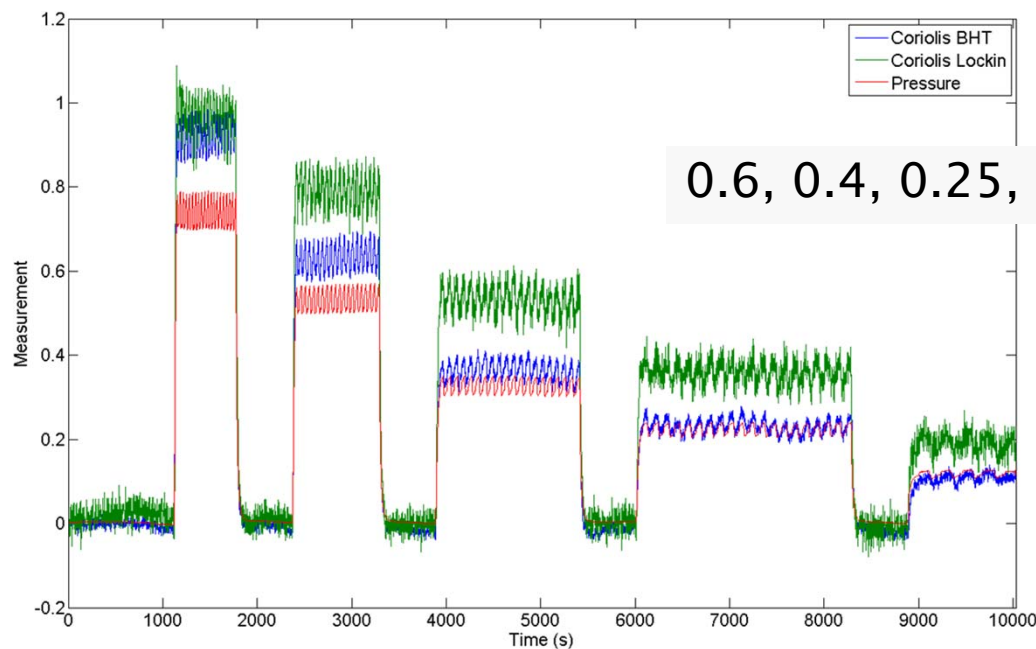
CleWin mask design

Other research topics

- ▶ Tube size and using parallel tubes
- ▶ Actuation
 - Using miniature magnets
 - Electrostatic actuation / parametric amplification
- ▶ Readout
 - Optimization of the capacitive readout
- ▶ Low-noise electronics
- ▶ Packaging / fluidic interconnects

First results

- ▶ First devices with by-pass channel have been fabricated.
- ▶ Filling of device with water did not give any problems.
- ▶ Further characterisation in progress



Conclusions

- ▶ Micro Coriolis flow sensors have been successfully fabricated
- ▶ Progress is being made on all aspects of the device.
- ▶ A design was made for hydrazine flow using an on-chip by-pass channel to increase the full-scale flow to 6 $\mu\text{l/s}$
- ▶ First devices with by-pass channel were fabricated.
- ▶ Initial measurements/characterization has started.

Acknowledgements

*The research leading to these results has received funding from the **European Community's Seventh Framework Programme ([FP7/2007–2013])** under grant agreement n° 282948*



Thank you for your attention!

Questions?

2.0kV

X25 1mm

39 25 SEI